



Single-crystal sapphire optical fiber sensor (DE-FC26-99FT40685) NETL Cross Cutting Review Meeting

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Outline

- Phase I and Phase II
 - Background
 - Sensing principle candidates
 - Laboratory tests
 - Field tests
- Phase III
 - Study on the property of sapphire fibers
 - Finalizing of the sensor structure
 - Silica-sapphire splicing technique
 - Optimization of optical system and data acquisition
 - Materials Selection
 - Probe Design
 - Field Testing



Motivation

- Temperature sensor for harsh-environments:
 - Coal gasifier
 - Gas turbine
- Temperature measurement is critical for:
 - Gasifier start-up
 - Process optimization
 - Insulation wear vs. coal slag transition.
 - Event/failure detection
- **Help make gasification cost-competitive**
 - Reduce down-time
 - Improve operational efficiency



Objective

- Objective:
To demonstrate the capability of an integrated sapphire optical temperature sensor through the development of sapphire based sensor assemblies and performance evaluation of the sensor on a full scale coal gasifier and a bench scale aero thermal turbine combustion rig.



Background: challenges

- Coal gasifiers - challenging harsh environment:
 - High temperatures: between 1100-1500°C.
 - Extreme corrosion:
 - coal slag
 - alkali vapors
 - transition metals



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P1&P2: Background

- Industrial need in high temperature measurement
- Review on existing technique
 - Non-optical: high temperature thermocouple, acoustic methods and gas-viscosity thermometry
 - Optical: remote pyrometry, thermal expansion thermometers, thermoluminescence thermometers and Rayleigh scattering thermometers
- Advantage of single crystal sapphire
 - Optical properties
 - Thermal-optic effects
 - Mechanical properties
 - Chemical inertness



P1&P2: Sensing principle candidates

- Principles:
 - Extrinsic Fabry-Pérot Interferometric (EFPI)
 - Polarized-light interferometric sensor (PLIS)
 - Broadband Polarimetric Differential Interferometry (BPDI)
 - EFPI sapphire wafer sensor
- Possible sensor designs
- Algorithm principles
- Estimation on the affect of harsh environment
 - Blackbody Radiation
 - Corrosion



P1&P2: Laboratory tests

- Sapphire fiber EFPI sensor
 - Too complicated to fabricate
 - Not suitable for industrial deployment
- Intensity based PLIS sensor
 - Structure not practical for industrial deployment
- Sapphire BPDI sensor
 - Free space structure has a high requirement for testing environment and low robustness
- Sapphire wafer EFPI sensor (chosen)
 - Compact, simple, robust and stable.



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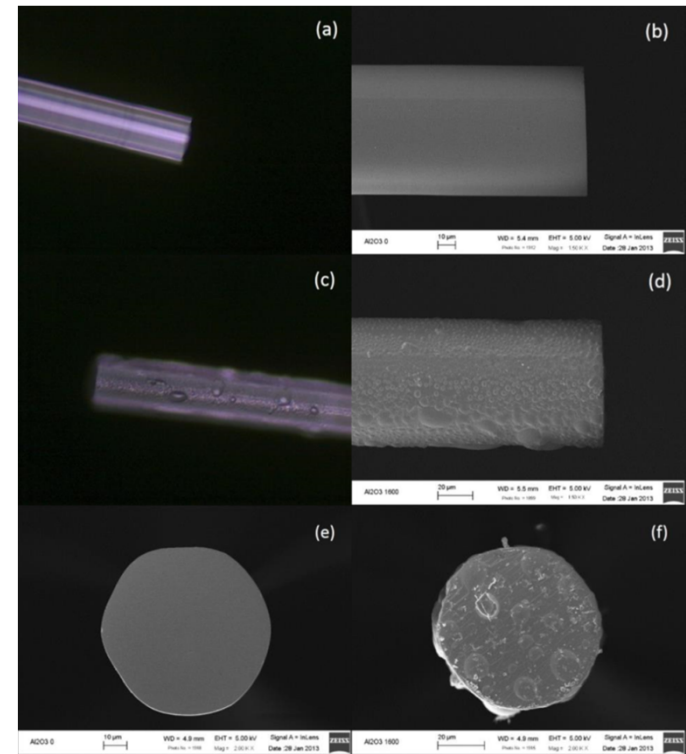
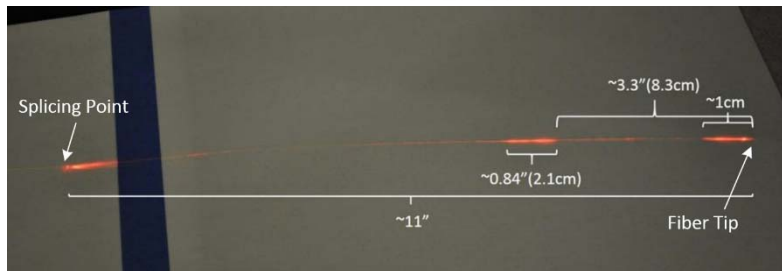
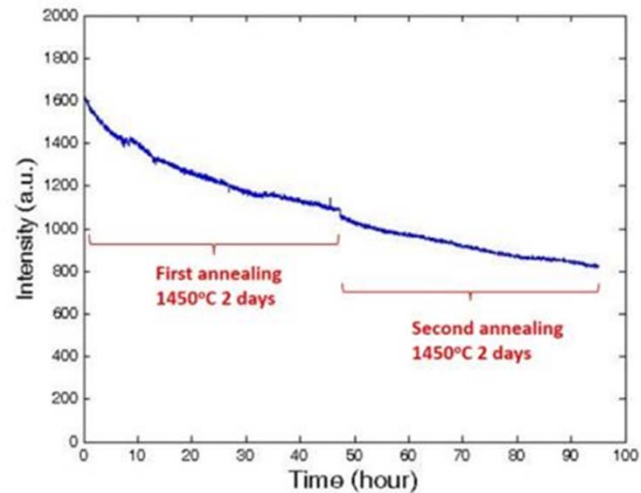
P1&P2: Field tests

- Wabash field test of BPDI sensor
 - No test were performed due to numerous logistical problems
- TECO field tests of sapphire wafer EFPI sensor
 - First (2006-2007): ~210 days of sensor lifetime demonstrated
 - Second (2006): ~20 days of sensor survival
 - Third (2007-2008): ~9 days of sensor survival
- Issues addressed: packaging and sensor long-term stability



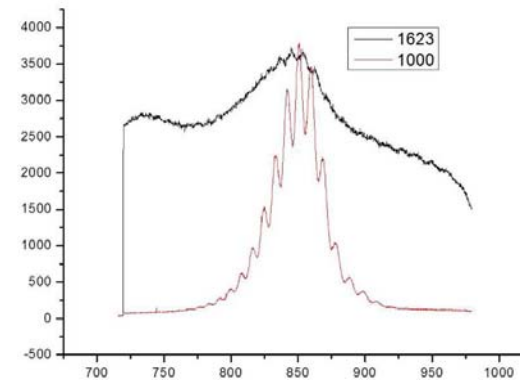
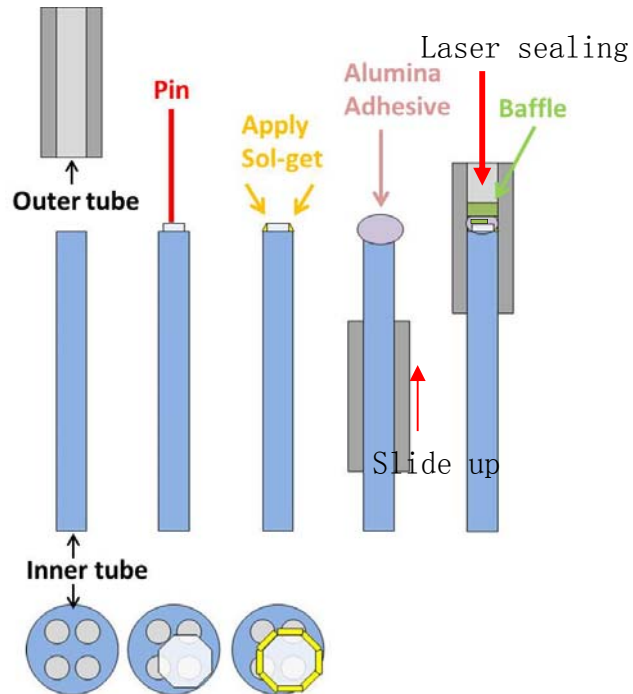
P3: Study on the property of sapphire fibers

- Study on contamination and decay of sapphire fiber



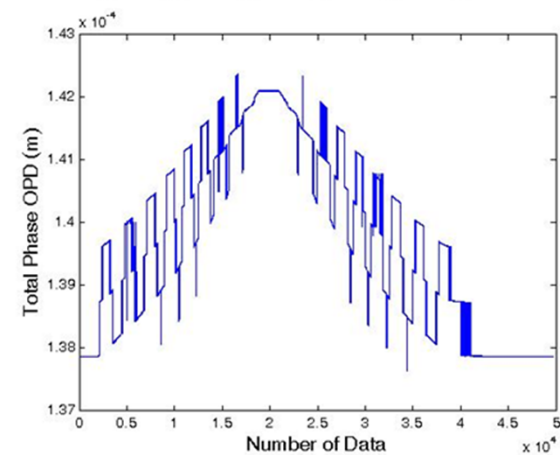
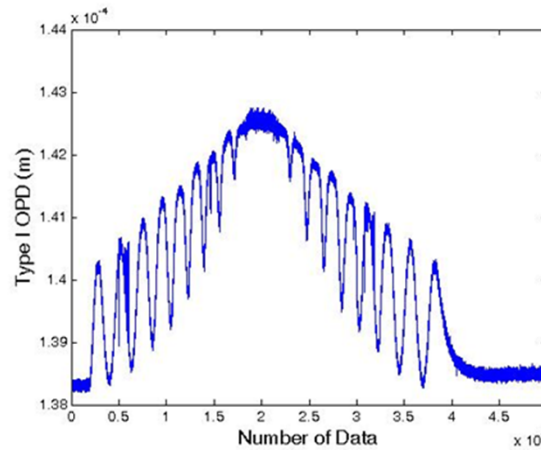
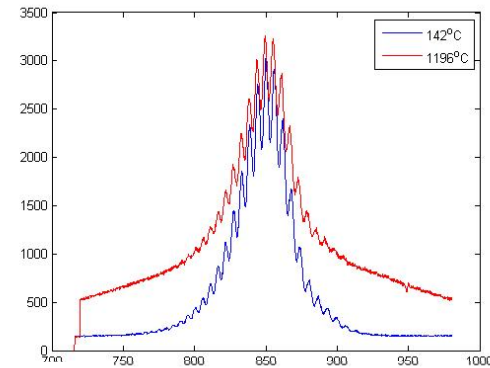
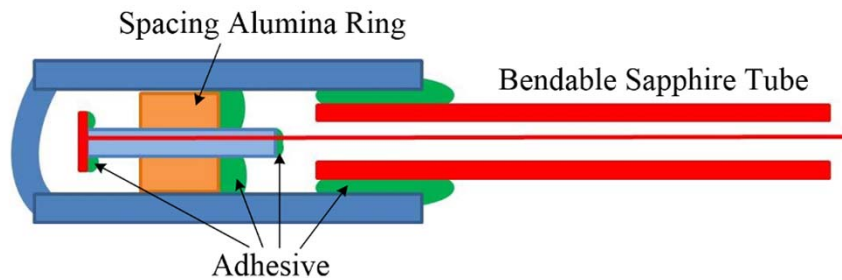
P3: Finalizing of the sensor structure

- Thermal fusion cap sealing technique



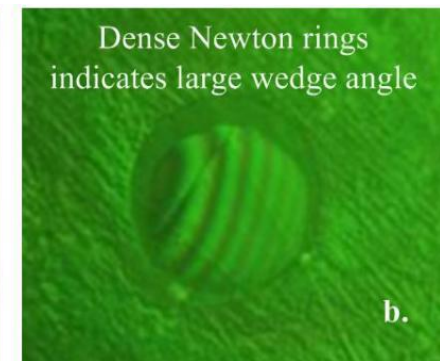
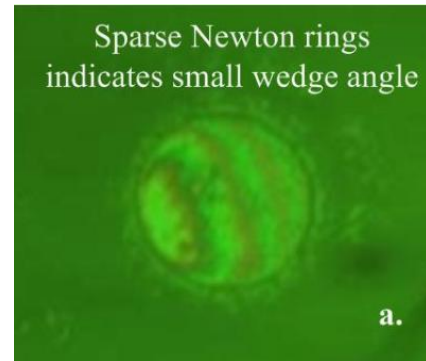
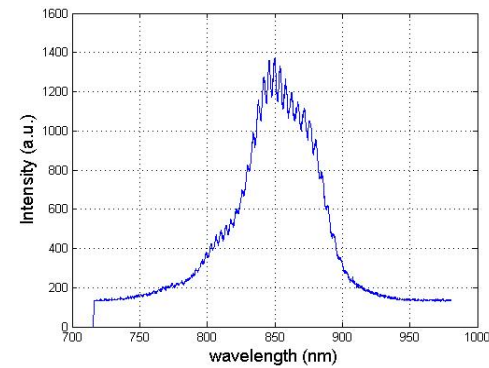
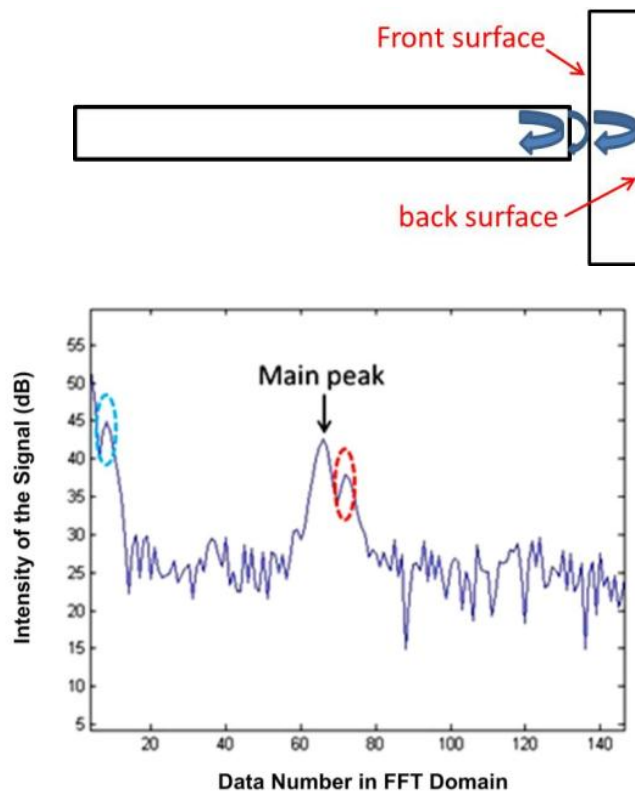
P3: Finalizing of the sensor structure

- Tube sealing sensor



P3: Finalizing of the sensor structure

- Addressing of multi-surface interference issue

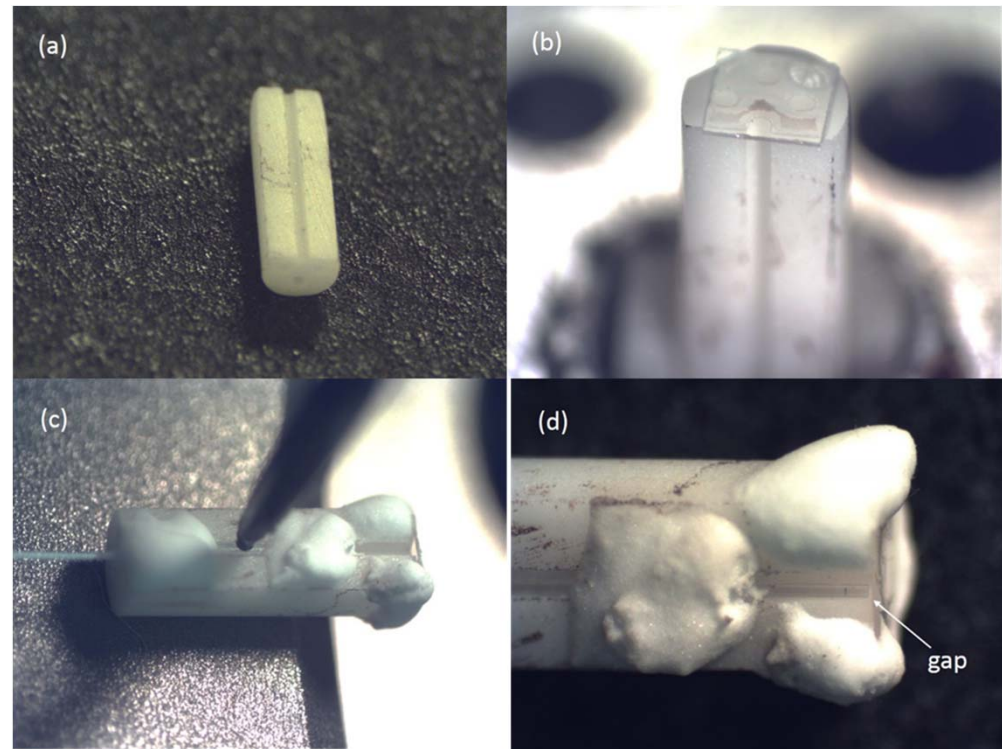
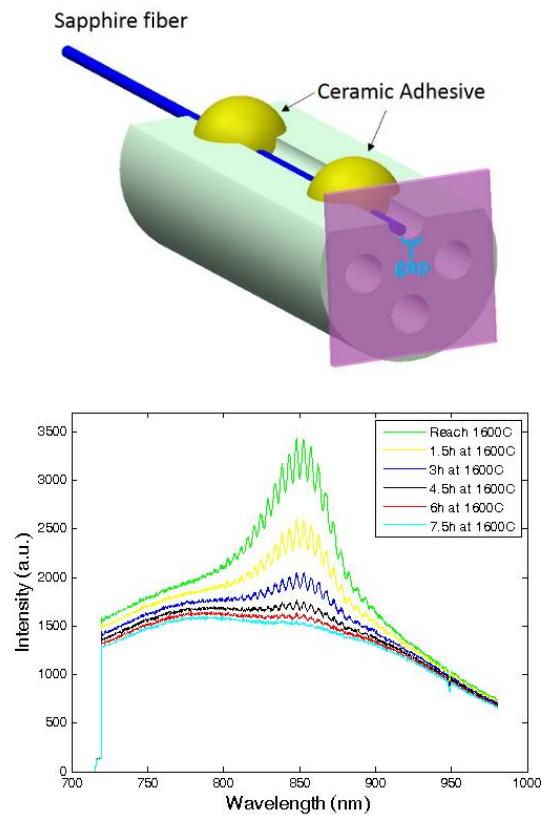


Angled polishing of fiber tip



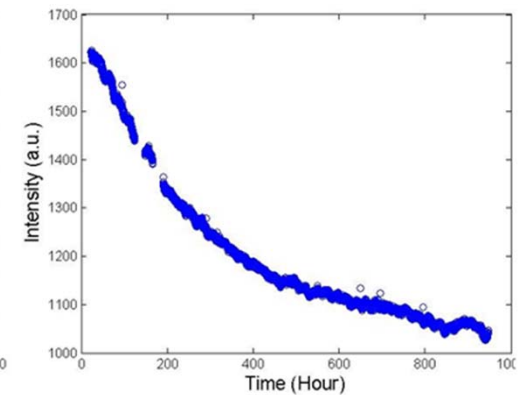
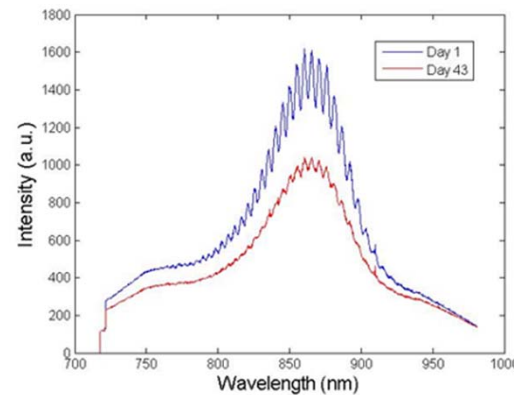
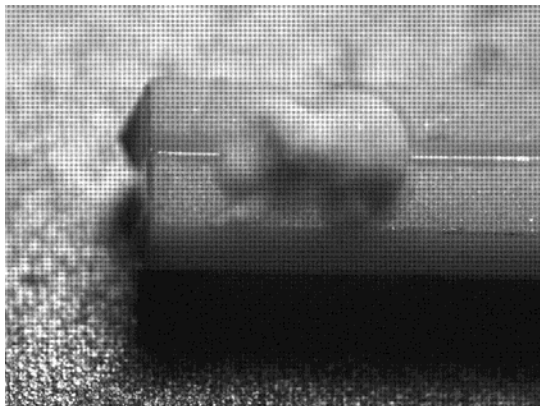
P3: Finalizing of the sensor structure

- Side polished sensor design



P3: Finalizing of the sensor structure

- Side polished sensor improvement

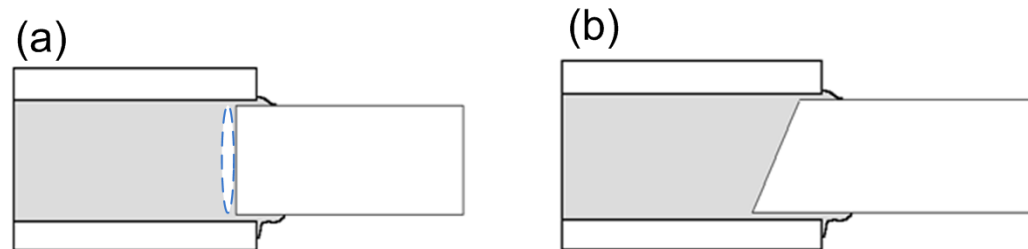


43 days lab test passed



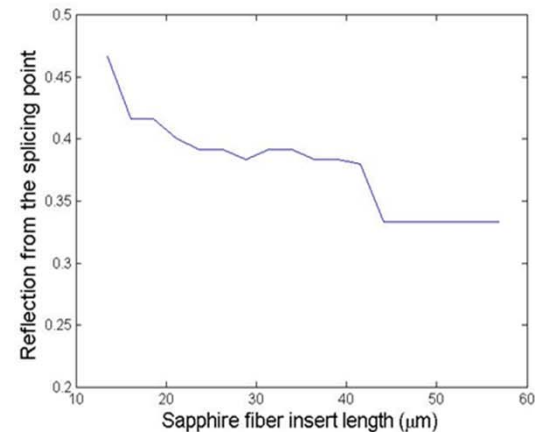
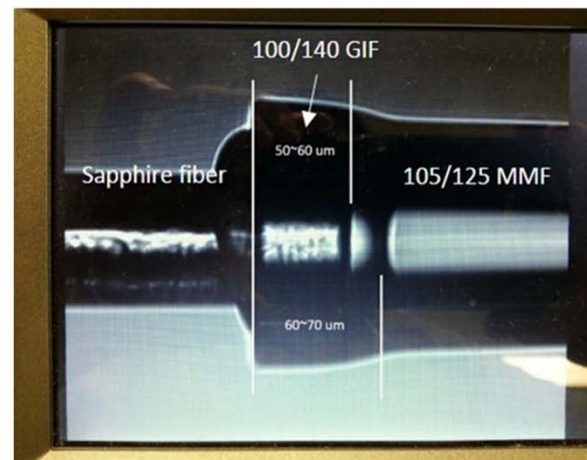
P3: Silica-sapphire splicing technique

- Choosing the right multimode fiber:
 - Nufern 100/140 MMF
 - OFS 105/125 MMF
- Attempt of angle-polished design to remove void in fiber core



P3: Silica-sapphire splicing technique

- Sapphire-100/140 MMF-105/125 MMF splicing scheme

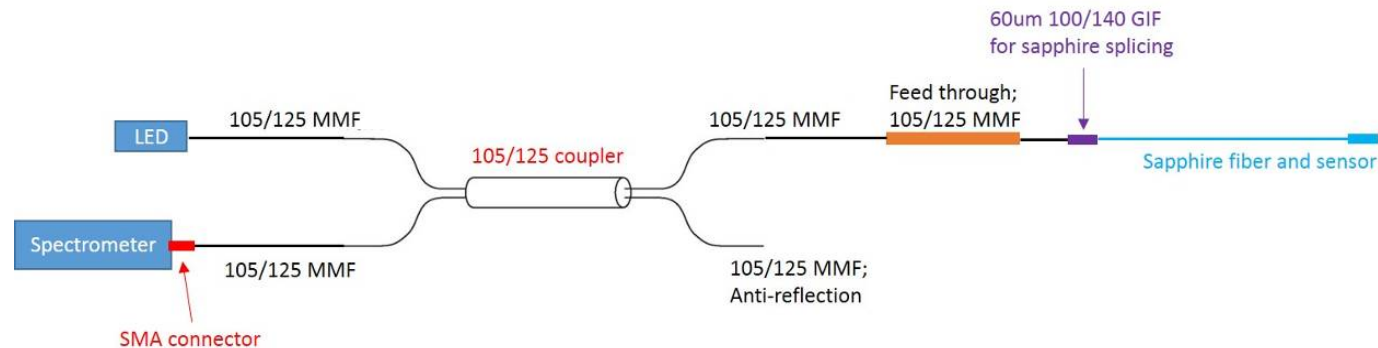


- Splicing point thermal endurance characterization
 - 600°C as the maximum surviving temperature
 - 400°C as the suggested working temperature



P3: Optimization of optical system and data acquisition

- Fiber system optimization

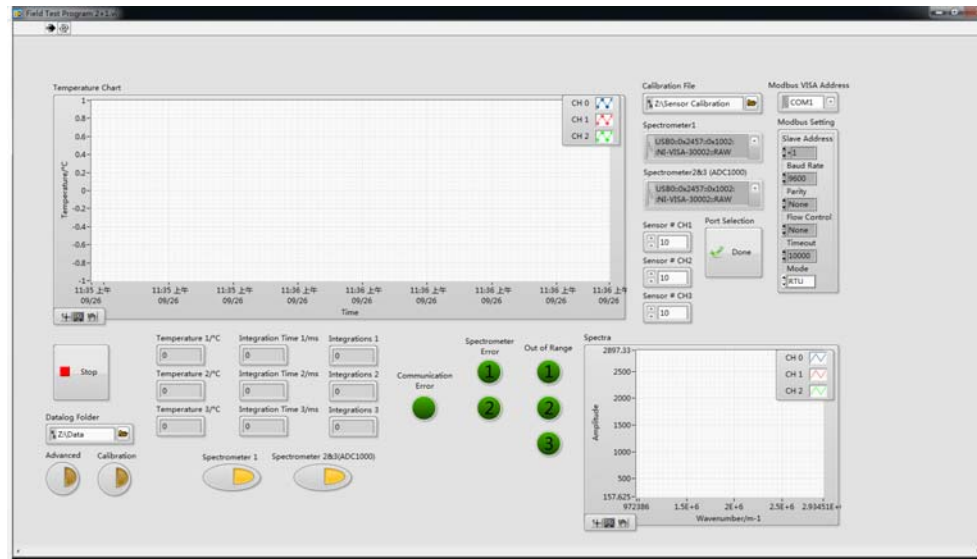


105/125 MMF for all system, including coupler and feedthrough. Effectively reduced loss and extended lifetime of sensors.



P3: Optimization of optical system and data acquisition

- Data Acquisition Software



Totally rewritten and fully tested. Now more stable, more flexible, more robust, jumping free in demodulation, and field-communication ready.



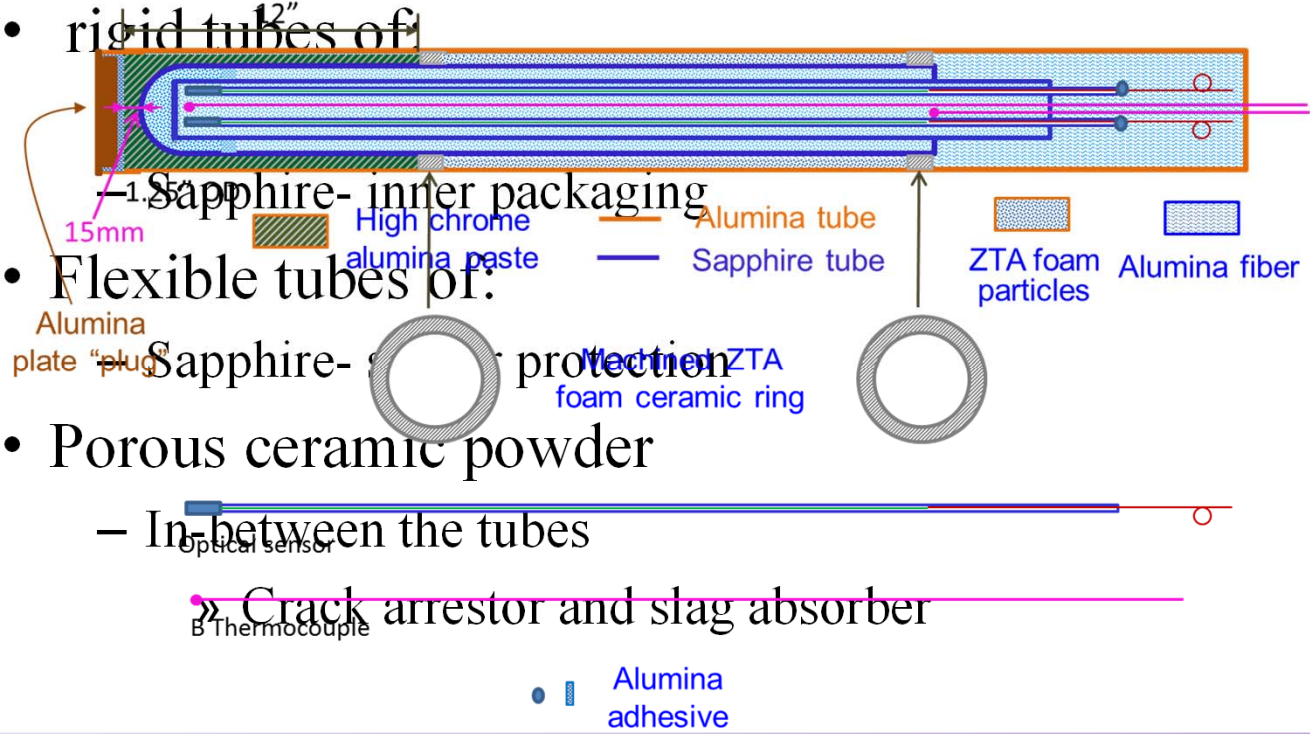
P3: Probe packaging design

- Based on the corrosion testing
 - Design utilized:

- rigid tubes of 12"

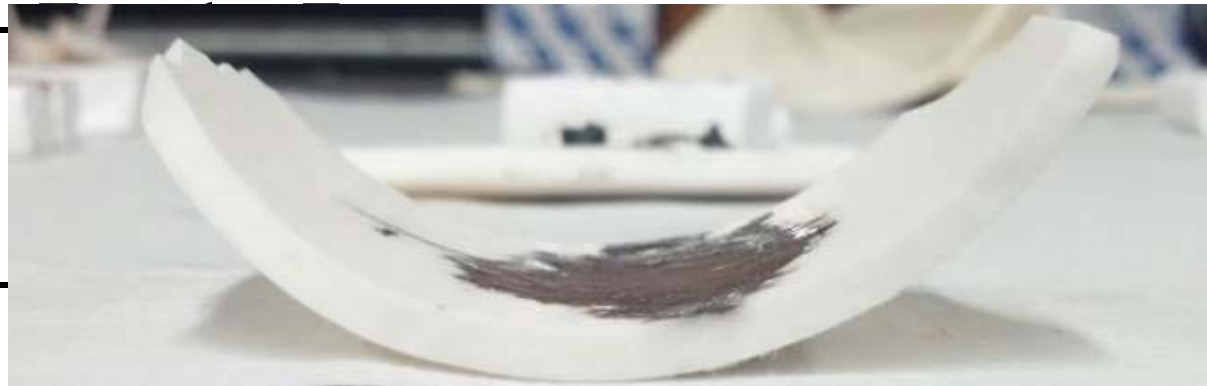
- Flexible tubes of:
 - Sapphire- inner packaging

- Porous ceramic powder
 - In-between the tubes
 - Crack arrestor and slag absorber



P3: Materials Testing and selection

- Materials testing for corrosion from coal slag

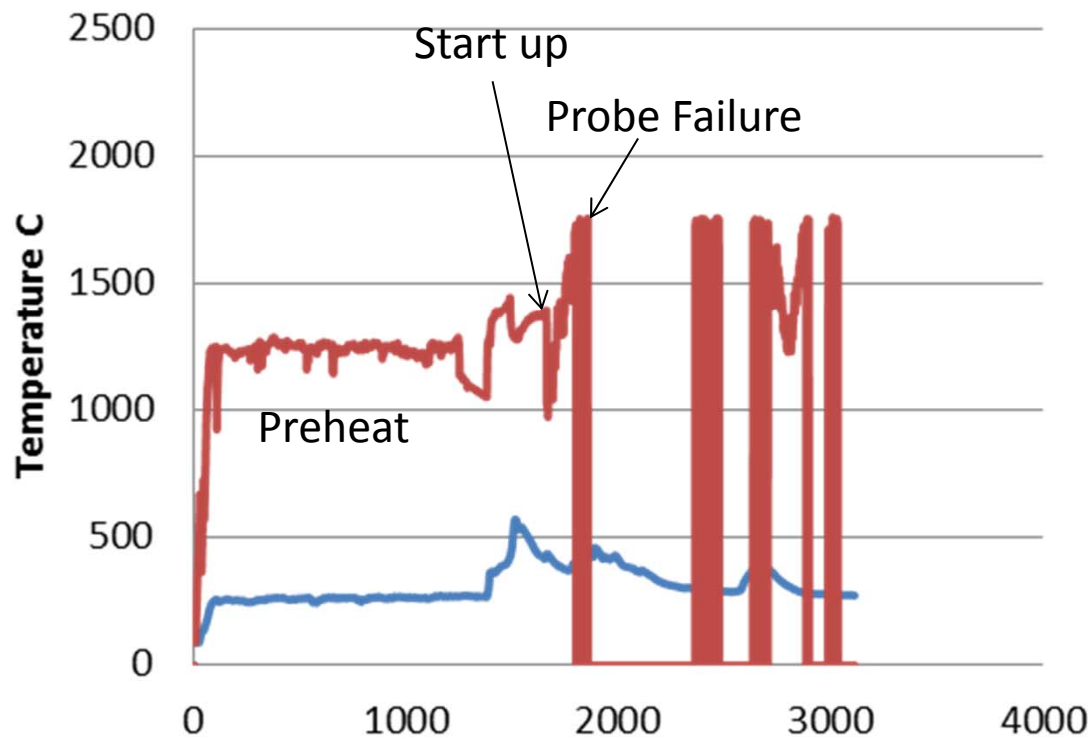


ide, hafnium



First blank probe results

Probe Temperature Readings



Preheat duration
~53 days

Time to failure after
Start up
~2.5 hours

— splice point

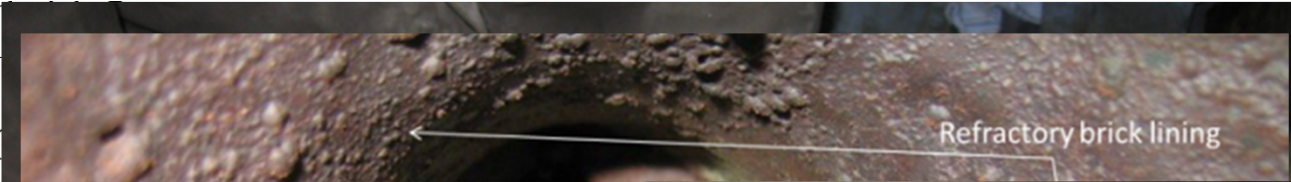
— probe tip



P3: Blank probe field test #1 results

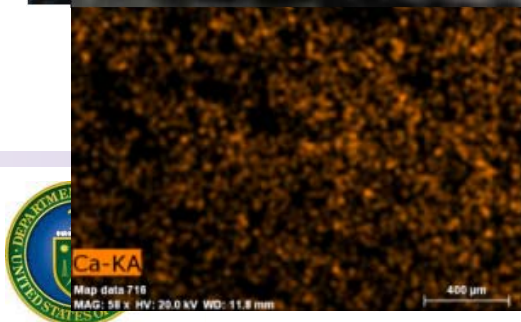
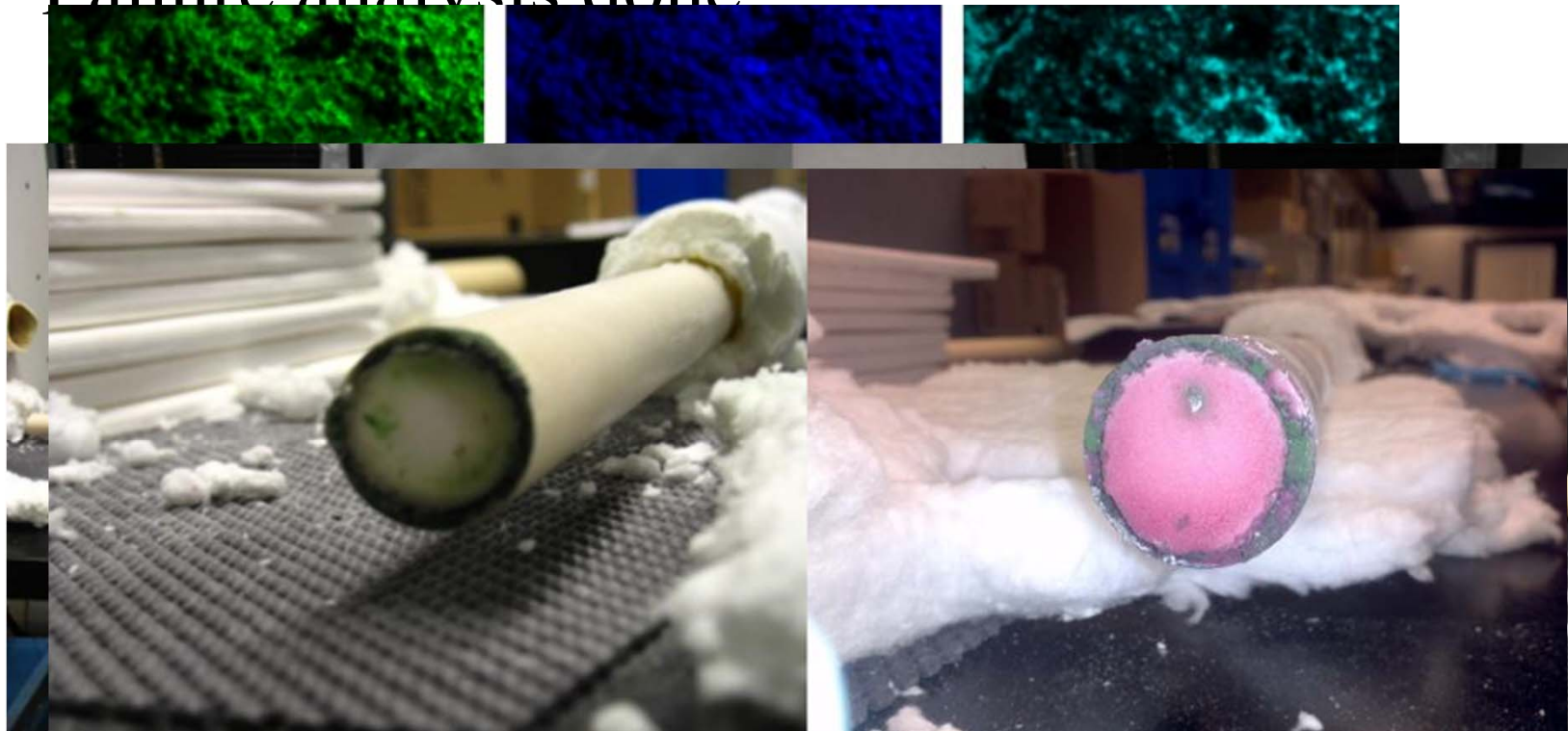
- Probe installed at Eastman Chemical on 2/0

– In



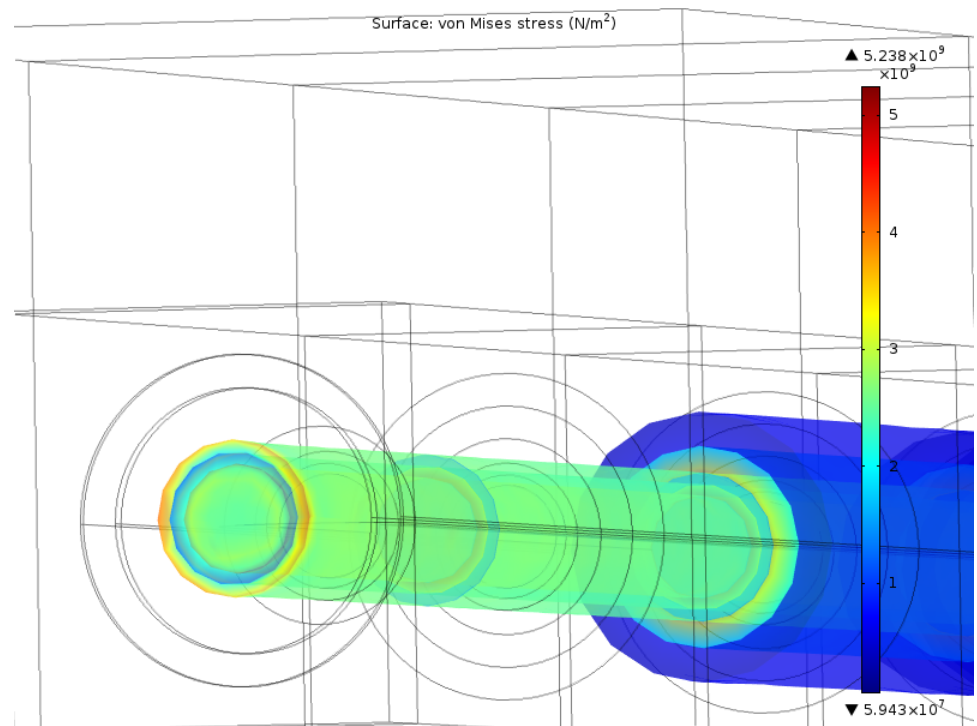
P3: Blank probe field test #1

- Failure analysis done



Progress updates: blank probe thermal modeling

- Sapphire tube surrounded by high chrome paste experienced stresses ranging from 1.5GPa-5GPa (220ksi-725ksi).
- Highest stress concentrations in corners.
- Yield strength of sapphire at room temperature is around 400MPa (58ksi).
- Yield strength drops to 325MPa (47ksi) at 1000°C.

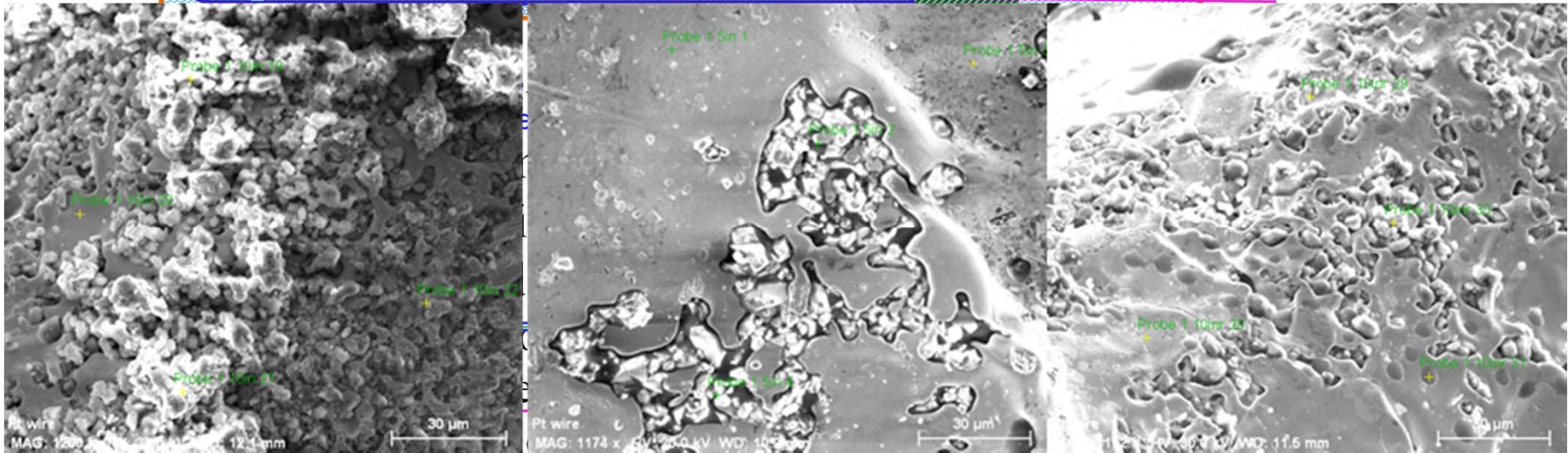
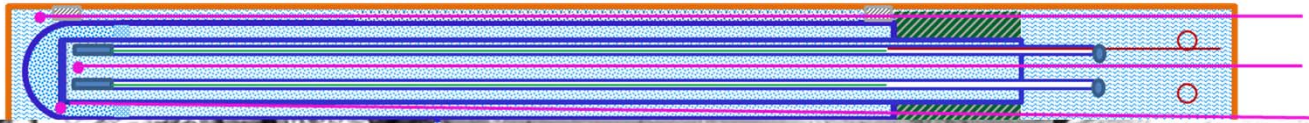


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P3: Blank probe field test #2

- Redesigned based on field test #1
 - Moved chrome paste to cold area

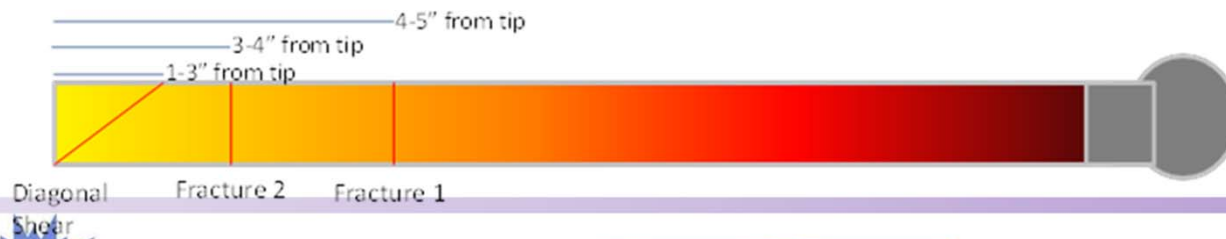
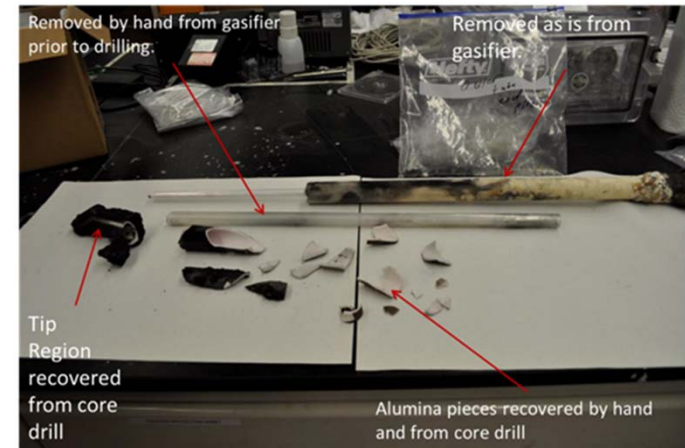


— Alumina adhesive

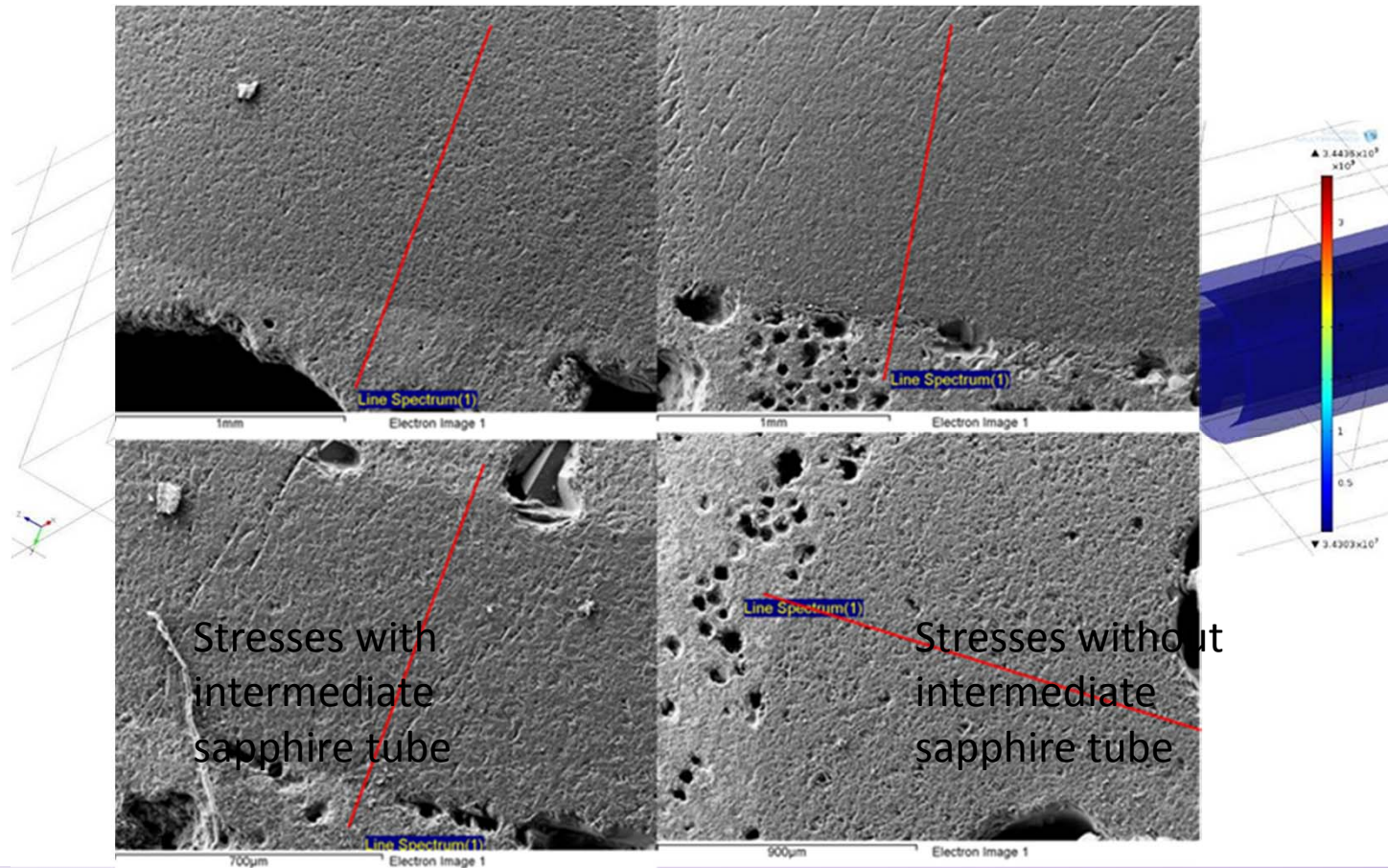


P3: Blank probe field test #2 results

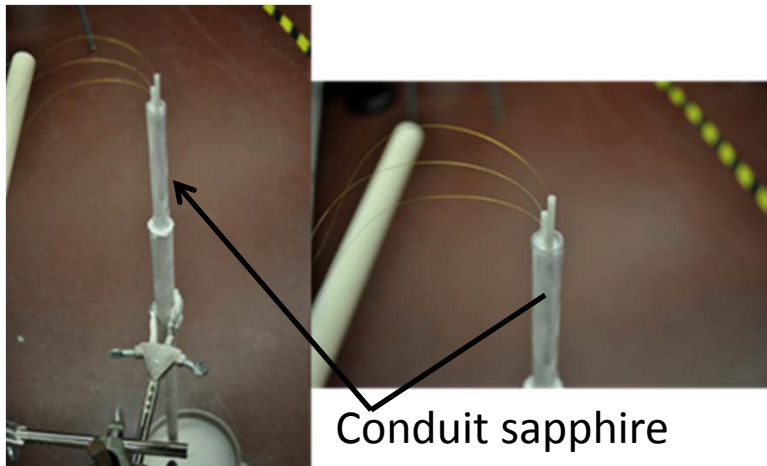
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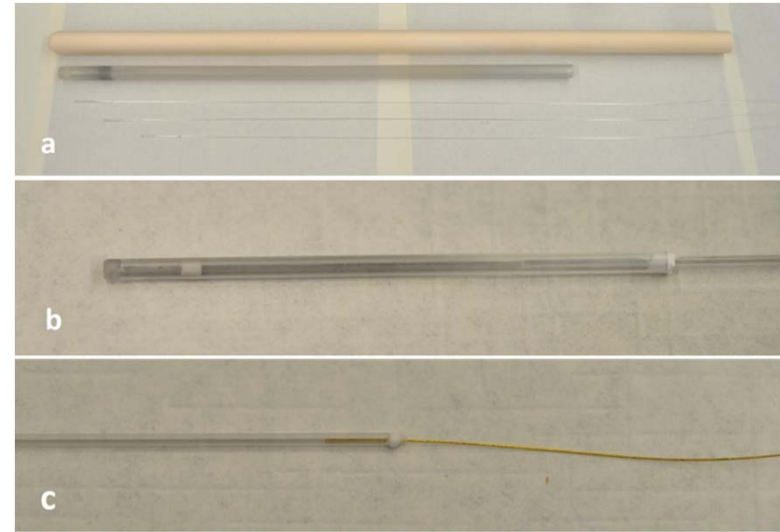
P3: Blank probe field test #2 results



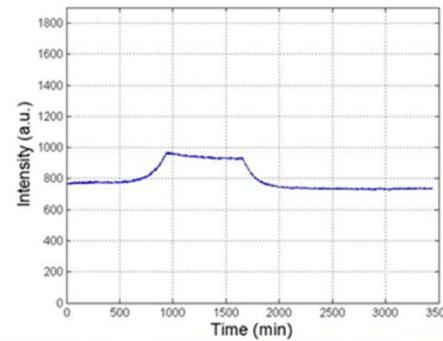
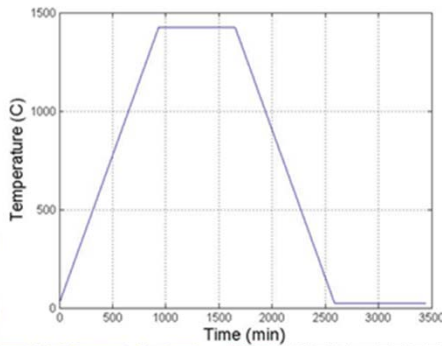
P3: Final Field test probe assembly



Conduit sapphire tube



Probe packaging components



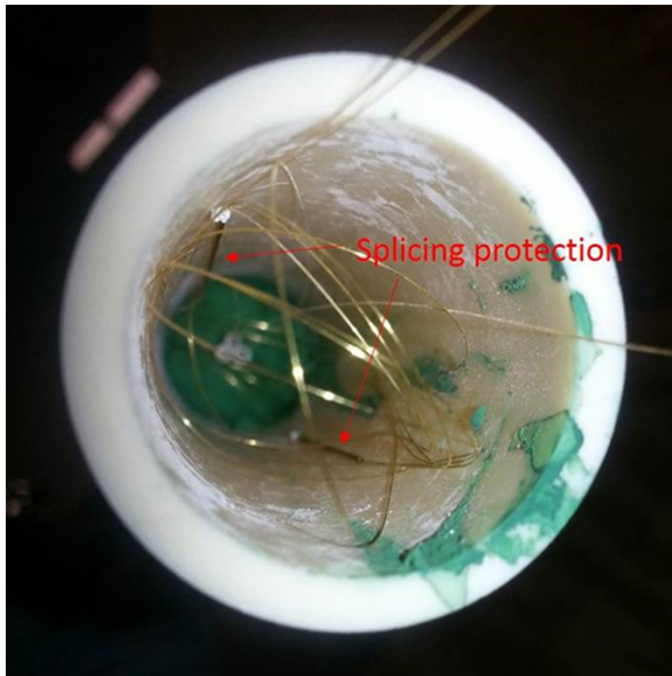
Sensor signal during final laboratory test



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P3: Final field test probe testing



Final packaging prior to flange attachment

Sensor #	S10	S11	S14	S15	S16	S18
Original total intensity (a.u.)	3193	3277	1789	3233	2377	3120
Total intensity after annealing	36%	65%	40%	62%	52%	57%
Original fringe contrast	0.232	0.192	0.204	0.184	0.193	0.221
Fringe contrast after annealing	85%	100%	80%	97%	85%	91%

Sensor stability



Summary

- Difficult environment to operate and experiment in:
 - Developments achieved
 - Long term sensor stability
 - Elevated T
 - Accurate & stable High T measurement
 - Harsh environment
 - Environment-material interaction understanding
 - Coal slag
 - Packaging
 - Temperature
 - Sapphire temperature instrumentation packing
 - High T
 - High T & corrosive environment



Thank you

- Questions?



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